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APPLICANTS

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** CONTINUING DATA *****
 none, ~~of~~ WLL

** FOREIGN APPLICATIONS *****
 REPUBLIC OF KOREA 2002-81480 12/18/2002 ~~of~~
 WLL

IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY **
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature Initials WLL	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 5	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
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TITLE
 Method of forming a buffer dielectric layer in a semiconductor device and a method of manufacturing a thin film transistor using the same

☐ All Fees